



INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)	ATTY. DOCKET NO. 043890-0646	SERIAL NO. 10/712,305
	APPLICANT Hiroyuki KITA, et al.	
	FILING DATE November 14, 2003	GROUP 2834

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mb		JP 62-057265	3-12-1987	Nippon Telegr & Teleph Corp <NTT>		English Abstract	
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		DUNN et al., "Substrate effects on domain structures of PZT 30/70 sol-gel films via PiezoAFM" Journal of the European Ceramic Society, Elsevier Science Publishers, Barking, Essex, GB, Vol. 22, no. 6, 2002, pp. 825-833, XP004339372
		KANNO et al., "Piezoelectric properties of c-axis oriented PbZr,TiO ₃ thin films", Applied Physics Letters, AIP, American Institute of Physics, Melville, NY, US, vol. 70, no. 11, March 17, 1997, pp. 1378-1380, XP012017420
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 1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.